

IN THE CLAIMS

Please cancel claims 1-16. Attached is a listing of the current claims.

17. (original) A carbon doped oxide film to be formed on a substrate from a carbon doped oxide precursor in the presence of oxygen.

18. (original) The carbon doped oxide film of claim 17 to act as an inter-layer dielectric between conductive lines deposited on said substrate following etching of said carbon doped oxide film.

19. (original) The carbon doped oxide film of claim 17 having a dielectric constant of less than about 3.0.

20. (original) The carbon doped oxide film of claim 17 formed at a rate exceeding about 5,620 angstroms per minute on said substrate.